I hereby-certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Africandria, VA 22313-1450

OVP EDated: February 15, 2007 Signature

signature: Jawa

Docket No.: VELOX 3.0-001

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Patent Application of:

Pophristic et al.

Application No.: 10/780,526

Applicación No.: 10/780,528

Filed: February 17, 2004

: Group Art Unit: 2811

: Examiner: S. A.

Gebremariam

For: LOW DOPED LAYER FOR NITRIDE-BASED SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the official action mailed November 15, 2006, applicant submits the following amendments and remarks.